Inventor: KITAOKA et al.
Docket No.: 10873.1420US01
Title: METHOD OF MANUFACTURING GROUP III NITRIDE SUBSTRATE AND SEMICONDUCTOR DEVICE
Attorney Name: Douglas P. Mueller
Phone No.: 612.371.5237
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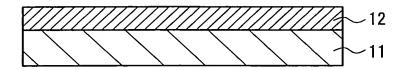


FIG. 1B

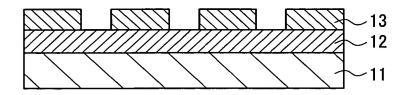
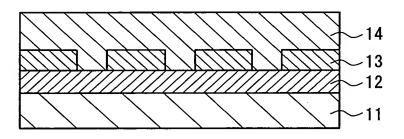
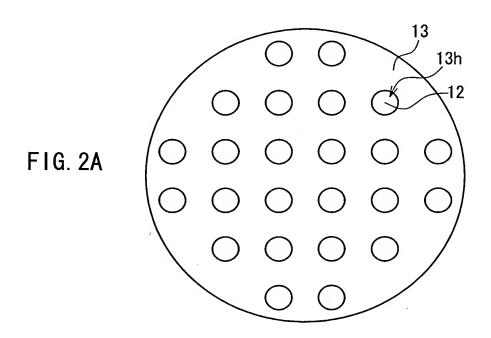


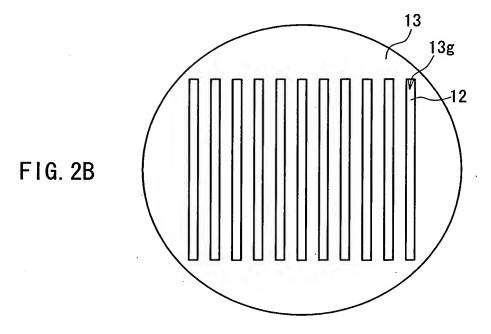
FIG. 1C



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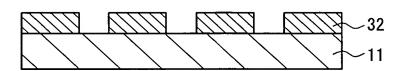


FIG. 3B

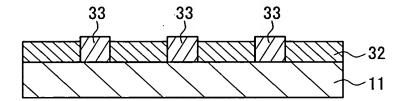
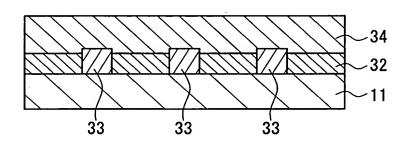


FIG. 3C



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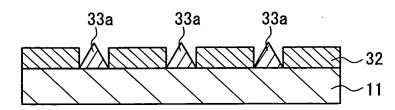
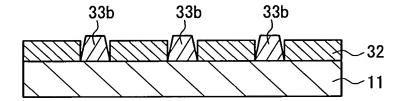
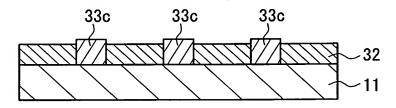


FIG. 4B







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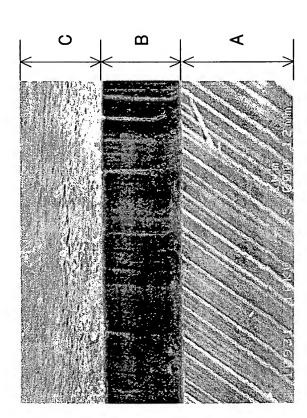
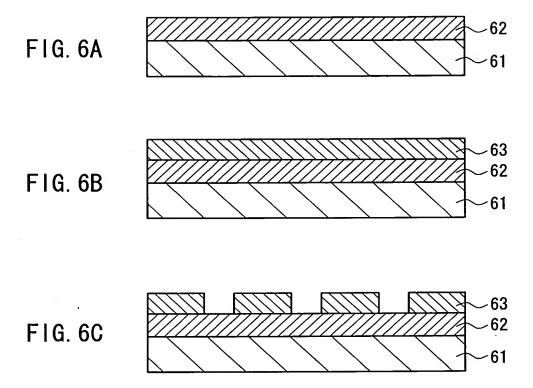
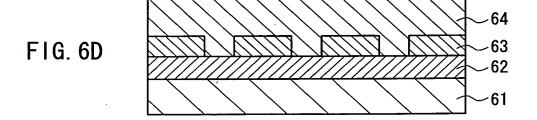


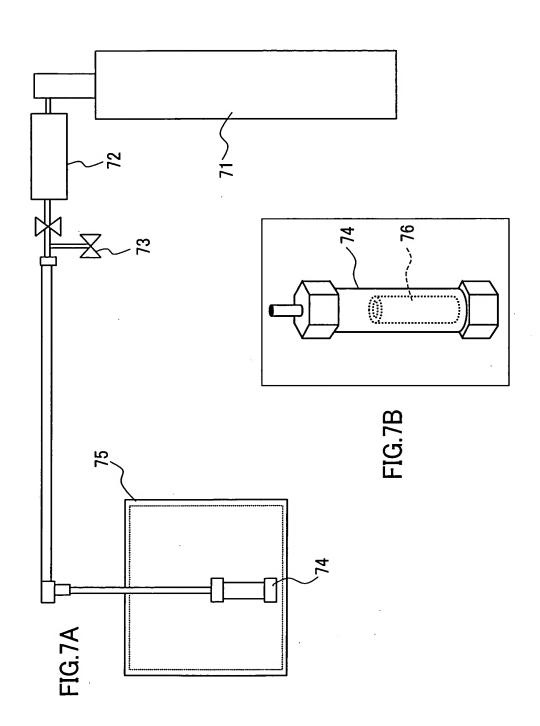
FIG.5

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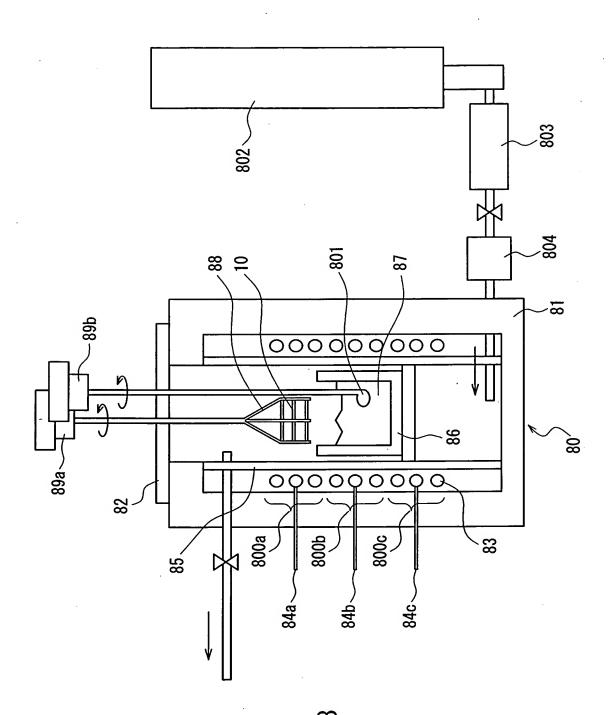




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F16.8

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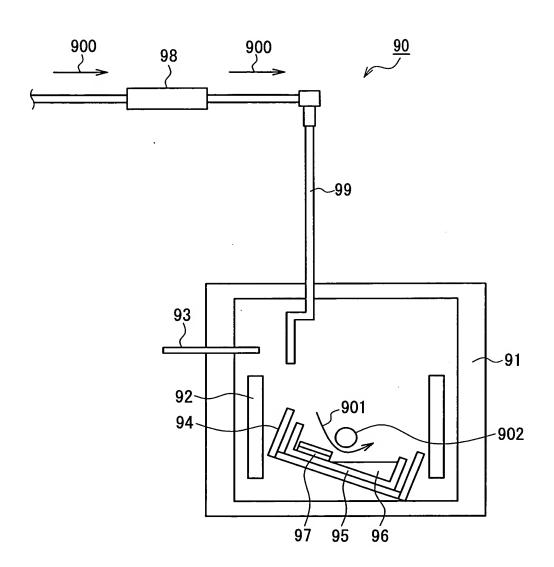
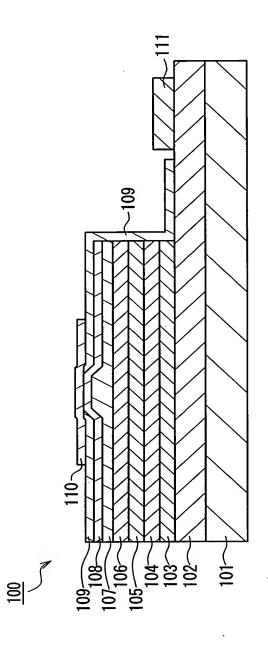
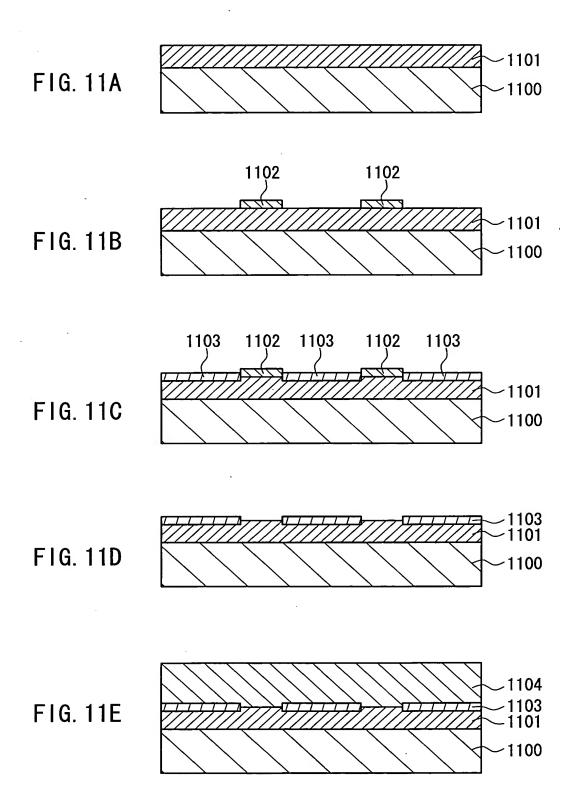


FIG. 9

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